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THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Haishan Zeng, *et al.*

Title: METHODS AND APPARATUS FOR FLUORESCENCE AND
REFLECTANCE IMAGING AND SPECTROSCOPY AND FOR
CONTEMPORANEOUS MEASUREMENTS OF
ELECTROMAGNETIC RADIATION WITH MULTIPLE
MEASURING DEVICES

Application No.: 10/028,568

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MAY 27 2003

Filing Date: December 19, 2001

TECHNOLOGY CENTER R3700

Attorney Docket No.: 1951-1-5

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited in the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 14th day of May, 2003.


Signature

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

May 14, 2003

Dear Commissioner:

In compliance with the duty of disclosure under 37 CFR § 1.56, Applicant submits herewith patents, publications, or other information for consideration during the examination of this application.

In accordance with 37 CFR § 1.97, the filing of this Information Disclosure

Statement shall not be construed to mean that a search has been made nor that the information cited in the statement is or is considered to be "material" to patentability as defined in 37 CFR § 1.56(b).

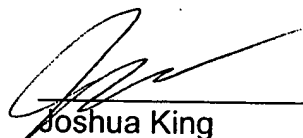
Certification Under Section 1.97(e)

The undersigned hereby certifies that this information was not known to individuals associated with the filing or prosecution of the subject patent application in accordance with Section 1.56(c) more than three months prior to the filing of this statement.

No additional costs are believed to be due in connection with the filing of this Supplemental Information Disclosure Statement. However, please charge any necessary fees in connection with the enclosed statement to our Deposit Order Account No. 07-1897.

Respectfully submitted,

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Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)	Docket Number (Optional) 1951-1-5	Application Number 10/028,568
	Applicant(s) Haishan Zeng, et al.	
	Filing Date December 19, 2001	Group Art Unit 3737

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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	6,083,158	7/4/2000	Bearman, Gregory H., et al.	600	323	9/1/1998
	5,982,493	11/9/1999	Lehnen, David Charles, et al.	356	375	6/2/1998
	5,900,942	5/4/1999	Spiering, Bruce A.	356	400	9/26/1997
	5,827,190	10/27/1998	Palcic, Branko, et al.	600	476	8/19/1996
	5,749,830	5/12/1998	Kaneko, Mamoru, et al.	600	160	10/27/1994
	5,255,087	10/19/1993	Nakamura, Kazunari, et al.	358	98	12/27/1991
	4,786,813	11/22/1988	Svanberg, Sune, et al.	250	461.1	10/22/1985
	4,768,513	9/6/1988	Suzuki, Susumu	128	634	3/30/1987
	4,556,057	12/3/1985	Hiruma, Teruo, et al.	128	303.1	3/11/1983

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	EP 0385608	9/5/1990	Europe	A61B	5/00		
	GB 2254417	10/7/1992	Great Britain	G01N	21/64		
	JP 10201707	8/4/1998	Japan	A61B	1/04	X (Abstract)	
	WO 99/53832	10/28/1999	PCT	A61B	5/00		
	DE 19842153 A1	3/16/2000	Germany	G02B	21/00		
	EP1058101 A2	12/6/2000	Europe	G01J	3/36	X (Abstract)	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	International Search Report, PCT/CA01/01824, February 28, 2003.
EXAMINER	DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609;
Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.